

**PATENT NUMBER and
ISSUE DATE**

U.S. UTILITY Patent Application

APPL NUM 10042154	FILING DATE 01/11/2002	CLASS 516	SUBCLASS 077	GAU 1712	EXAMINER <i>METZMAIER</i>
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**APPLICANTS: Ishitobi Ken; Kumita Tetsuro; Hon Kimihiro; Suzuki Yoshinori;

****CONTINUING DATA VERIFIED:**

THIS APPLN CLAIMS BENEFIT OF 60/260,883 01/12/2001
AND A CIP OF PCT/JP01/05800 07/04/2001

**** FOREIGN APPLICATIONS VERIFIED:**

JAPAN 2000-204163 07/05/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO Q62628
TITLE : Polishing composition and magnetic recording disk substrate polished with the polishing composition			

U.S. DEPT. OF COMM /PAT & TM-PTO-435L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
ISSUE FEE	Amount Due		Total Claims	Print Claim for O.G.
TERMINAL	Date Paid	DRAWING		
		Sheets Drwg.	Figs.Drwg.	Print Fig.
		Primary Examiner		
		PREPARED FOR ISSUE		Application Examiner
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